



CERTIFICATE OF MAILING

37 C.F.R. §1.8

I hereby certify that this paper is being deposited with the U.S. Postal Service as First-Class Mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date shown below:

Date

Susan F. Mahon

Docket No. 8733.20019

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jin JANG, et al.

GAU: TBA

SERIAL NO: 09/350,313

EXAMINER: TBA

FILING DATE: July 9, 1999

FOR: Method of Crystallizing Amorphous Silicon Layer and Crystallizing Apparatus Thereof

RESPONSE TO NOTICE TO FILE MISSING PARTS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

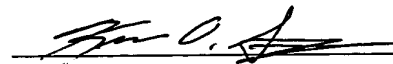
In response to the Notice to File Missing Parts - Filing Date Granted, mailed August 6, 1999, Applicants submit the attached executed Declaration, Form PTO-1533, and a check in the amount of \$1,324.00 to cover the filing fee due of \$1,084.00, the surcharge fee of \$130.00, and the one-month extension fee of \$110.00.

In the event any additional fees are required in connection with this paper, please charge Deposit Account No. 50-0911. A copy of this document is enclosed.

Applicants' undersigned attorney may be reached in our Washington office by telephone at (202) 624-1200. All correspondence should be directed to the below-listed address.

Respectfully submitted,

LONG ALDRIDGE & NORMAN, LLP

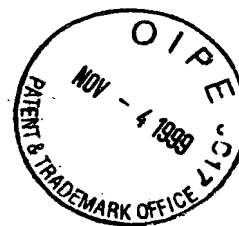

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Re: Serial No.: 09/350,313
Applicant(s): Jin JANG, et al.
Filing Date: July 9, 1999
For: Method of Crystallizing Amorphous Silicon Layer and Crystallizing Apparatus Thereof
Group Art Unit: TBA
Examiner: TBA

SIR:

Attached hereto for filing are the following papers:

Request for Extension of Time (1-month)
Response to Notice to File Missing Parts w/Form PTO-1533 & executed Declaration

Our check in the amount of \$1,324.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. §1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 50-0911. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. §1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

LONG ALDRIDGE & NORMAN LLP

Kenneth D. Springer
Attorney of Record
Registration No.: 39,843